## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Christophe MALEVILLE

Confirmation No.: 7699

Application No.: 10/619,446

Group Art Unit: 1772

Filing Date: July 16, 2003

Examiner:

For:

METHOD OF INCREASING THE AREA

OF A USEFUL LAYER OF MATERIAL TRANSFERRED ONTO A SUPPORT

Attorney Docket No.: 4717-5800

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Pursuant to Applicant's duty of disclosure under 37 C.F.R. § 1.56, listed on the enclosed Form PTO-1449 are three (3) references for the Examiner's review. A copy of reference "C" is attached herewith.

It is respectfully requested that the references be made of record in this application by the Examiner's completion and return of the attached Form PTO-1449. No fee is believed to be due for the submission of the these references. Should any fees be required, however, please charge such fees to Winston & Strawn Deposit Account No. 50-1814.

Respectfully submitted,

Nov. 6, 2003

E. Bradley Gould

(Reg. No. 41,792)

For: Allan A. Fanucci

(Reg. No. 30,256)

WINSTÓN & STRAWN Customer No. 28765

202-371-5771

					ATTY. DOCKET NO.:	ATTY, DOCKET NO.:		APPLICATION NO.:		
LIST OF REFERENCES CITED BY APPLICANT					4717-5800		10/619,446			
OIPE		Form PTO-1	APPLICANT:							
(Use several sheets if necessary)					Christophe MALEVILLE					
MOV n.c. 2000					FILING DATE:		GROUP:			
	3	Sheet 1 of 1			16 July 2003					
V.S. PATENT DOCUMENTS										
*EXAMINER INITIAL	CITE NO.	DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	FILING APPROF	DATE IF	
	Α	6,429,104	08/2002	Auberton-Herve		438	527			
	В	5,374,564	12/1994	Bruel		437	24			
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FOREIGN PATENT DOCUMENTS										
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)										
M.K. Weldon et al., "Mechanism of Silicon Exfoliation by Hydrogen Implantation and He, Li and Si										
Co-implantation," Proceedings 1997 IEEE International SOI Conference, October, 1997, pp. 124-25										
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EXAMINER DATE CONSIDERED										
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in										
conformance and not considered. Include copy of this form with next communication to applicant.										

DC:331298.1